

# Microwave Journal

## DESIGN ENABLEMENT FOR RF AND MICROWAVE IC DESIGN: PART I

**Editor's Note:** *This two-part series from Jazz Semiconductor presents recent developments in design support methodology from a pure-play wafer foundry specialized in RFCMOS and advanced CMOS technologies including BiCMOS, SiGe BiCMOS and high voltage CMOS. In part one, the authors describe how the integration of RF and digital blocks produce the functionality for today's advanced electronics but results in IC complexity that makes shotgun-style prototyping impractical, and how extensive device modeling, simulation and a methodology design enablement tool is imperative for successful analog intensive/mixed-signal IC design.*

**T**he gigahertz era in consumer electronics has catalyzed the convergence of RF and microwave applications with mainstream large-scale semiconductor technology. This merging of technology has brought performance, manufacturability and time-to-market requirements into the forefront of a world once driven solely by design-to-specification. Stand-alone microwave circuits are rapidly moving to analog intensive mixed-signal

(AIMS) microwave ICs. Not too long ago, the quick manufacturing cycles of III-IV technologies allowed for countless fabrication iterations of microwave designs before reaching final design and subsequent mass production. These iterations were carried out in prototype vehicles that included tens of individually tweaked

versions of a single IC. Later rather than sooner, one of the versions would function, and be selected for production. As these products are plugged into larger scale integrated chips, the high development cost and cycles associated with these technologies make it difficult to survive using this shotgun approach.

When microwave circuits enter the mixed-signal world, they must adapt to function in the mixed-signal process technology. For this adaptation to be successful, the design flow must facilitate the design of optimized microwave modules with the available technology. **Figure 1** displays Jazz RF Analog Design Enablement, a novel design platform that delivers robust models and design tools intimately tied to the manufacturing process directly

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to the IC designer's desk. Application of design enablement to the RF and microwave design space facilitates the innovation of highly differentiated products. The flow starts with a physical, scalable modeling platform combined with a robust statistical infrastructure to simulate design sensitivity to process variation, thus enabling first-time-right semiconductors. The modeling platform resides in a leading commercial IC design environment, which provides scalable parameterized cells for all components with embedded process technology knowledge, facilitating direct design space exploration and optimization. Finally, tools for final loop closure between fabricated silicon and simulation provide a feedback mechanism for continual design improvement.

**FRONT END DESIGN  
ENABLEMENT: MODELING  
METHODOLOGY**

The RF IC designer creates a highly complex integrated circuit,

which executes complicated functions at various levels of the system. In the end, regardless of the level of abstraction in which an RF system is defined, the semiconductor transistors and integrated passives do the work. Thus, the designer needs to know how these devices perform, in particular how they respond to electrical, magnetic and thermal stimuli. Device models provide this information to the designer. One can think of models as the prescription glasses a designer must be fitted with before the IC design process commences. Different technologies such as RFCMOS, SiGe BiCMOS, or GaAs come with a different prescription, enabling a designer to understand the process and thus make decisions on how to design the particular IC.

An accurate modeling platform consists of a set of physical compact models that are accurately characterized to the semiconductor technology and, just as importantly, are readily available within the IC design environment. The models must not only

reflect the nominal process, but also accurately predict the natural process variation of semiconductor technology. All production IC designs are ultimately subject to the semiconductor manufacturing process variation over the life of the product. Hence, the design must be robust and meet performance specifications, or "yield,"

**Physical Compact Modeling**

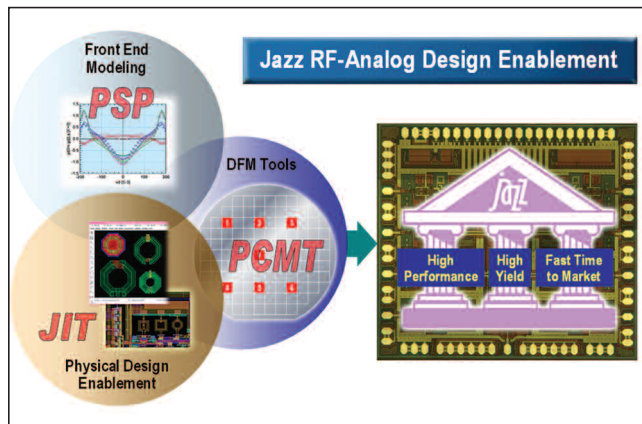
across the entire process variation space. Therefore, statistical models representing the process variation of the technology must be available within the design environment.

A compact model is a set of analytical equations that describe the electrical, electromagnetic and thermal behavior, implemented in a SPICE-like simulation tool. The models make necessary simplifications from the full physics while retaining sufficient accuracy and reasonable simulation times. As a somewhat simplified assertion, one can state that the simulation time is directly proportional to the complexity of the model. Consequently, the best compact models contain simplifications that retain accuracy while improving speed.

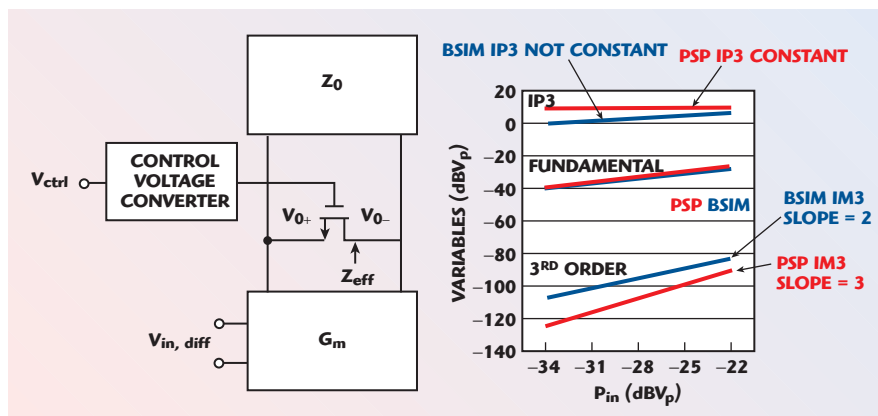
Physically based compact models are based on the fundamental process parameters that control the device behavior, such as oxide thickness for the MOS devices and base doping for an NPN. Additionally, compact models should be formulated based on the geometrical variables including scalable design parameters and process design rules. Examples of scalability include gate length and width of a MOSFET or GaAs FET, emitter length and width of bipolars, and inductor line widths and number of turns. Examples of process design rules include poly to contact, deep trench and active area spacing.

Compact models should be  $C_{\infty}$  continuous over the entire operating range of a device, where  $C_n$  continuous means the function and its  $n^{th}$  order derivatives are continuous as described by McAndrew.<sup>1</sup> Additionally, models should provide correct asymptotic behavior to the extremes of input stimulus such as voltage or temperature. Such requirements ensure robust simulation convergence behavior and model accuracy in regions not measured during model characterization.

As semiconductor technology has advanced, so has compact modeling. Modern day compact models meet all the requirements previously mentioned providing robust simulation performance and accuracy. Examples of three advanced, state-of-the-art compact models (PSP, MOSVAR and JIT), offered as part of the Jazz Ana-



▲ Fig. 1 High level capabilities required for first-pass microwave/mixed-signal IC design based on Jazz RF-Analog Design Enablement.



▲ Fig. 2 RF attenuator schematic and harmonic distortion analysis.

log Design Environment, are highlighted next.

**PSP**

The PSP model, the next generation standard compact MOSFET model, is an advanced surface potential-based model geared towards 90 nm and below technology nodes.<sup>2</sup> Furthermore, the PSP model remedies many issues with the well-known prior generation model BSIM, making it quite effective for older technologies such as 0.18  $\mu\text{m}$ . PSP provides the best model for RF analog design through complete physical

treatment of noise sources including gate and channel noise correlation, and continuous high order derivatives crucial for distortion analysis. An example of the effectiveness of the PSP model for distortion simulation is presented here.

There are several RF circuit blocks that utilize the MOSFET in a passive context such as passive mixers and RF attenuators. **Figure 2** shows a simplified diagram of an RF attenuator based on a transconductance amplifier configuration, a circuit block commonly used in RF transceiver design. The GM block combined with

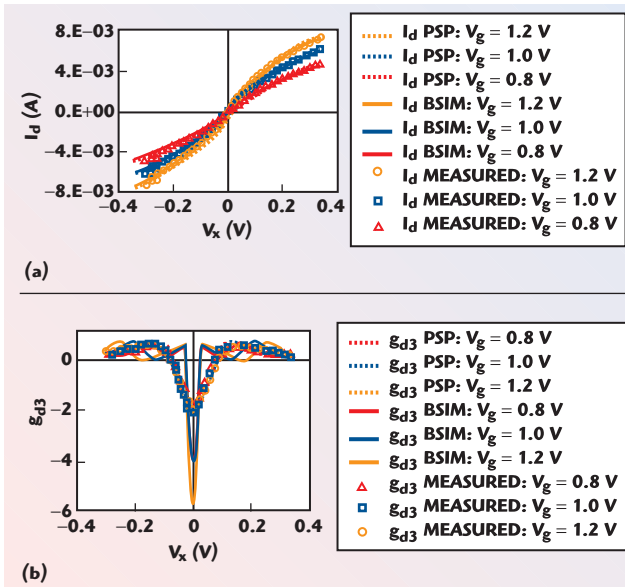
the load impedance  $Z_0$  sets the attenuation or gain of the block. A common and effective design technique utilizes an NFET hooked with the drain and source across the differential output signal, DC biasing the device at  $V_{ds} = 0$ . The gate voltage is then controlled through automated gain control (AGC) circuitry to modulate the channel resistance, changing the effective load impedance  $Z_{eff}$ , thus modulating the

attenuation (or gain) of the block. The figure also shows intermodulation distortion simulations for the attenuator, based on the PSP and BSIM MOSFET model. At low input power levels, the third harmonic (IM3) must exhibit a slope of three based on harmonic power series analysis. The BSIM model simulates a slope of two, which is physically incorrect and leads directly to incorrect simulation of third-order intermodulation distortion, or IP3 analysis. By contrast, PSP exhibits the correct slope of three for IM3 and thus the expected IP3 results.

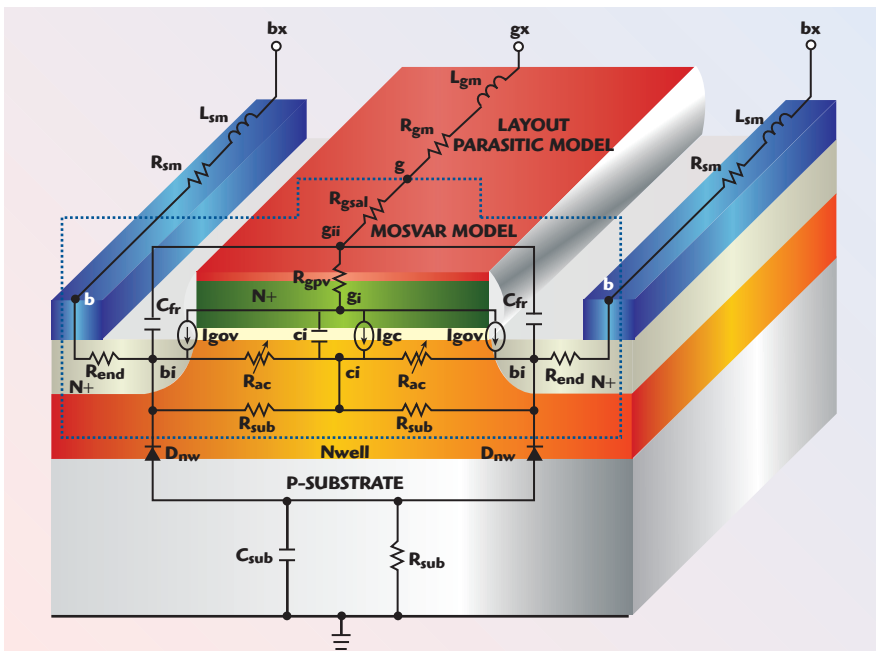
At the very root of this problem is the discontinuity of the high order derivatives at the  $V_{ds} = 0$  point in the BSIM model.<sup>3</sup> **Figure 3** shows the results of the well-known Gummel symmetry tests for a NFET in the Jazz SiGe/RFCMOS SBL13 0.13  $\mu\text{m}$  technology. The NFET is swept symmetrically across the  $V_{ds} = 0$  point, with the drain current and the third derivatives plotted. The clear third derivative discontinuity in the BSIM model produces the IIP3 slope = 2. PSP displays not only continuous behavior at the third derivative, but tracks the data very reasonably. An RF designer can then design such a key block and others that depend on the accuracy around the  $V_{ds} = 0$  point such as RF passive mixers and switches with a high degree of confidence.

**MOSVAR**

Design of RF/analog and millimeter wave circuits requires accurate, scalable compact models not only for the active transistors but, just as critically, the passive components in a given technology. This includes the MOS varactor, which provides frequency tuning for circuits such as voltage-controlled oscillators (VCO). VCOs provide frequency synthesis and system timing in many modern day RF systems, such as WLAN, WiMAX, UWB, automotive radar and high speed optical communications systems.<sup>4,5,6</sup> The recently developed MOSVAR model shown in **Figure 4** is a physically based scalable model for MOS varactors.<sup>7</sup> The model includes a PSP-based analytical surface potential charge formulation and physical geometry and process parameter-based parasitic modeling. The model provides highly accurate simu-



▲ Fig. 3 0.13  $\mu\text{m}$  NFET Gummel symmetry test; (a)  $I_d$  and (b)  $g_{d3}$ .



▲ Fig. 4 MOS varactor cross-section and model circuit.

lations of key varactor performances such as capacitance and quality factor  $Q$  over voltage, frequency and geometry. Above all, the model provides the physical insights to the designer, enabling design trade-offs such as phase noise vs. oscillator gain.

In a typical VCO tank circuit, an integrated inductor ( $L$ ) and a MOS varactor ( $C$ ) set the oscillation frequency. The tank quality factor ( $Q_{\text{tank}}$ ), which directly affects the VCO phase noise, is given by

$$Q_{\text{tank}} = \frac{Q_L Q_C}{Q_L + Q_C} = \frac{\omega L}{R_L + \omega^2 L C R_C} \quad (1)$$

derived using the approximations for the tank components:

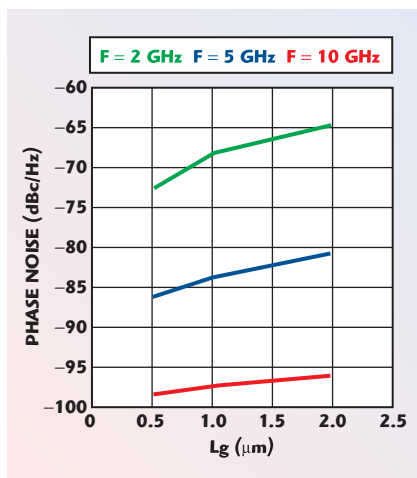
$$Q_L = \omega L / R_L, \quad Q_C = 1 / \omega C R_C \quad (2)$$

$R_X$  (where  $X$  denotes  $L$  or  $C$ ) is the resistive loss for each component in the series tank path. Equation 1 shows that at low frequencies,  $Q_{\text{tank}}$  is controlled by the inductor while at high frequencies  $Q_{\text{tank}}$  is controlled by the MOS varactor. Leeson's phase noise model<sup>8</sup> provides direct insight into the varactor impact on phase noise (PN). It relates the PN transfer function  $H(j\Delta\omega)$  to the oscillator parameters by

$$|H(j\Delta\omega)|^2 = \frac{1}{4(Q_{\text{tank}})^2} \left( \frac{\omega_0}{\Delta\omega} \right)^2 \quad (3)$$

where

$\omega$  = oscillator center frequency  
 $\Delta\omega$  = offset frequency where the phase noise measurement is taken



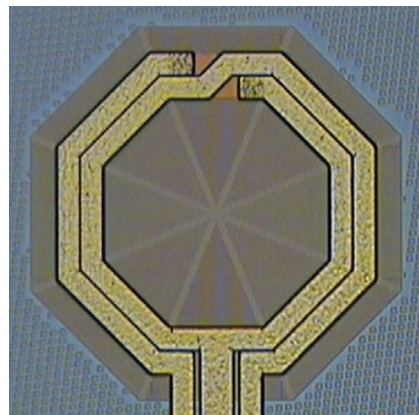
▲ Fig. 5 Phase noise dependence on MOS varactor gate length.

At frequencies where  $Q_C$  dominates Equations 1 and 3 show that  $|H(j\Delta\omega)|^2 \propto (R_C)^2$ . **Figure 5** shows PN simulations of the VCO with the MOSVAR model.

PN increases with  $L_g$ , as expected due to the increased  $R_C$  from the Nwell resistance. In addition,  $dPN/dL_g$  increases at higher frequencies above 5 GHz due to the increased influence of  $Q_C$  compared to  $Q_L$ . The physical, scalable nature of the MOSVAR model provides direct insight into the MOS varactor influence on PN with respect to frequency and geometry, facilitating design of stringent RF and millimeter-wave VCO design criteria such as low phase noise.

### Jazz Inductor Toolbox (JIT)

In addition to providing the complimentary tank element to the varactor in VCOs, integrated inductors and baluns are key components to RF and millimeter design where they are heavily used in filtering and impedance matching applications. The Jazz Inductor Toolbox (JIT) provides a comprehensive inductor design environment including scalable compact models and parameterized layout cells, delivering a turnkey design solution to the IC designer.<sup>9</sup> JIT feeds the technology parameters (for example, metal sheet resistance, interlayer dielectric thickness and substrate resistance) directly into a set of comprehensive analytical equations for the self and mutual inductance, parasitic resistance including high frequency skin effects and capacitance. The general void of this in the industry often leaves designers to custom inductor design through a time-consuming iterative process of EM simulation and/or silicon verification.



▲ Fig. 6 Microscope image of octagonal inductor over ground shield.

This inductor toolbox provides a comprehensive, scalable library of inductors applicable to a large design space. The library includes conventional single-ended spirals common to filtering and impedance matching in power amplifiers. Symmetrical inductors enable the use of differential circuit design, well-known to produce improved linearity, noise immunity and common mode rejection ratio (CMRR) in transceiver design. Supported inductor styles include octagonal geometries, which enhance  $Q$  performance through reduction in parasitic resistance and capacitance. Additionally, scalable patterned ground shields provide additional  $Q$  boost combined with enhanced noise isolation critical to RF systems. **Figure 6** shows a microscope photograph of a symmetric inductor over a ground shield. Designers can also leverage a scalable passive library for characterization of transmission lines and other components such as tees and bends. As the infrastructure includes high frequency effects, the broadband output models produce low risk and rapid RF design validation.

### CONCLUSION

In the first part of this series, the role of microwave circuits as primary building blocks of communications systems and their expansion into new industries and applications such as AIMS is considered. We examined how the lines separating microwave and consumer commodity products have vanished. Under these conditions, new breeds of microwave products are leveraging semiconductor technologies that decisively allow for integration of high value functionality in a cost-effective manner. As these analog-only circuits evolve into integrated AIMS solutions, a design flow that delivers robust models and tools intimately tied to the manufacturing process is requisite in the pursuit of performance, manufacturability and time-to-market. As an example of such a flow, the Jazz RF Analog Design Enablement has been presented as a state-of-the-art methodology that promotes the design of first-time-right optimized microwave modules. In the second part of this series, examples of modeling methods, physical design and loop closure tools will be showcased as illustrations of design enablement. ■

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